

UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE PATENT TRIAL AND APPEAL BOARD

MICRON TECHNOLOGY, INC.,
Petitioner

v.

YANGTZE MEMORY TECHNOLOGIES COMPANY, LTD.,
Patent Owner

Case No. IPR2025-00117
U.S. Patent No. 10,672,711

PETITIONER'S UPDATED EXHIBIT LIST

LISTING OF EXHIBITS

EXHIBIT NO.	DESCRIPTION
1001	U.S. Patent No. 10,672,711 to Zhu et al. (“the ’711 patent”)
1002	File History of U.S. Patent No. 10,672,711 (“the ’711 FH”)
1003	Declaration of Dr. Sanjay Banerjee (“Banerjee”)
1004	<i>Curriculum Vitae</i> of Dr. Sanjay Banerjee
1005	U.S. Patent Publication No. 2012/0070944A1 to Kim et al. (“Kim”)
1006	Korean Patent No. 10-2015-0051841 to Park et al. (“Park”) including certified translation
1007	U.S. Patent Publication No. 2019/0067306A1 to Fang et al. (“Fang”)
1008	U.S. Patent Publication No. 2017/0294384A1 to Chen (“Chen”)
1009	Aritome, “NAND Flash Memory Technologies” (2016)
1010	Silvagni, “3D NAND Flash Based on Planar Cells,” Computers 2017
1011	Micheloni et al., “Inside Solid State Drives (SSDs)” (2nd Ed. 2018)
1012	U.S. Patent Publication No. 2017/0117222A1 to Kim et al.
1013	Chang and Sze, “ULSI Technology” (1996)
1014	Orlowski et al., <i>Si, SiGe, Ge, and III-V Semiconductor Nanomembranes and Nanowires Enabled by SiGe Epitaxy</i> , ECS Transactions Vol. 33, No. 6 (2010), 777-89
1015	U.S. Patent No. 9,728,547 to Ohsaki et al.
1016	U.S. Patent Publication No. 2017/0148677A1 to Shin

EXHIBIT NO.	DESCRIPTION
1017	U.S. Patent Publication No. 2013/0313627A1 to Lee et al.
1018	Minute Order (case schedule), Dkt. No. 141, dated September 18, 2024 in <i>Yangtze Memory Technologies Company, Ltd. v. Micron Technology, Inc. and Micron Consumer Products Group, LLC</i> , Case No. 3:23-cv-05792-RFL
1019	Combined Civil and Criminal Federal Court Management Statistics (December 31, 2023), available at https://www.uscourts.gov/sites/default/files/data_tables/fcms_na_distcomparison1231.2023.pdf
1020	Plaintiff and Counterclaim Defendant Yangtze Memory Technologies Company, LTD.'s Disclosure of YMTC II Asserted Claims and Infringement Contentions, dated October 2, 2024 in <i>Yangtze Memory Technologies Company, Ltd. v. Micron Technology, Inc. and Micron Consumer Products Group, LLC</i> , Case No. 3:23-cv-05792-RFL
1021	Docket from <i>Yangtze Memory Technologies Company, Ltd. v. Micron Technology, Inc. and Micron Consumer Products Group, LLC</i> , Case No. 3:24-cv-04223-RFL which has been consolidated with Case No. 3:23-cv-05792-RFL
1022	Declaration of Jared Bobrow in Support of Petitioner's Motion for Admission <i>Pro Hac Vice</i>
1023	Declaration from Mel DeSart, University of Washington regarding Chang and Sze, <i>ULSI Technology</i> (1996) (<i>served only – not filed</i>)
1024	Leibniz Information Centre for Science and Technology University Library accession confirmation regarding Chang and Sze, <i>ULSI Technology</i> (1996) (<i>served only – not filed</i>)

EXHIBIT NO.	DESCRIPTION
1025	Declaration of Jeremy Jason Lang regarding Orłowski et al., <i>Si, SiGe, Ge, and III-V Semiconductor Nanomembranes and Nanowires Enabled by SiGe Epitaxy</i> , ECS Transactions Vol. 33, No. 6 (2010), 777-89 (<i>served only – not filed</i>)
1026	Declaration of Mina Ching (Internet Archive) regarding Orłowski et al., <i>Si, SiGe, Ge, and III-V Semiconductor Nanomembranes and Nanowires Enabled by SiGe Epitaxy</i> , ECS Transactions Vol. 33, No. 6 (2010), 777-89 (<i>served only – not filed</i>)
1027	Transcript of November 7, 2025 deposition of Stephen Campbell, Ph.D.
1028	Reply Declaration of Dr. Sanjay Banerjee (“Banerjee2”)
1029	U.S. Patent Publication No. 2013/0228837A1 to Sukekawa et al. (“Sukekawa”)
1030	U.S. Patent Publication No. 2007/0075428A1 to Wang et al. (“Wang”)
1031	USPTO Memorandum, Enforcement and Non-Waiver of 37 C.F.R. §42.104(b)(4) and Permissible Uses of General Knowledge in <i>Inter Partes</i> Reviews (July 31, 2025)
1032	Dhungana et al., <i>Combinatorial Survey of Fluorinated Plasma Etching in the Silicon-Oxygen-Carbon-Nitrogen-Hydrogen System</i> , Journal of Vacuum Science and Technology A (2016), 061302-1–18
1033	Declaration of Sylvia D. Hall-Ellis regarding Ex. 1032, Dhungana et al., <i>Combinatorial Survey of Fluorinated Plasma Etching in the Silicon-Oxygen-Carbon-Nitrogen-Hydrogen System</i> , Journal of Vacuum Science and Technology A (2016), 061302-1–18 (Served Only)
1034	Petitioner’s Hearing Demonstratives

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Respectfully submitted,

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CERTIFICATE OF SERVICE

The undersigned hereby confirms that the foregoing paper was caused to be served on March 10, 2026 via electronic mail, upon the following attorneys of record for the Patent Owner:

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